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I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on: September 23, 2005

Signed: Michelle Chan

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appln. No. : 10/674,071 Confirmation No.: 1212
Applicant : Stephen Empedocles et al.
Filed : September 30, 2003
TC/A.U. : 2876
Examiner : Hess, Daniel A.

Docket No. : 01-001701
Customer No. : 33140
Title : Applications of Nano-Enabled Large Area Macroelectronic
Substrates Incorporating Nanowires and Nanowire Composites

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

The references cited on the attached form PTO-1449 are being called to the attention of the Examiner. Pursuant to 1276 OG 55 dated August 5, 2003, Applicants are not providing copies of US patents and/or publications as this application was filed after June 30, 2003.

It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR §1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is made that a search has been conducted or that this statement encompasses all possible relevant information.

09/26/2005 ZJUHA1 00000009 502336 10674071

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Appl. No. 10/674,071
Stephen Empedocles et al.

This information disclosure statement is being filed after the mailing date of the first Office Action and more than three months after the filing date, but prior to the mailing of a Notice of Allowance or Final Office Action. Authorization to charge the appropriate fee to the undersigned's deposit account is submitted herewith. Please charge any additional fees or credit any overpayment to Deposit Account No. 50-2336.

Respectfully submitted,



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SEP 23 2005

(Modified) PTO/SB/08A-B (08-03)

Approved for use through 7/31/2006. OMB 0651-0031

Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Complete if Known		
		Application Number	10/674,071	
		Filing Date	September 30, 2003	
		First Named Inventor	Empedocles	
		Art Unit	2876	
Examiner Name	Hess, Daniel A.			
Sheet		of	Attorney Docket Number	01-001701

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document No.	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, lines, Where Relevant Passages or Relevant Figures Appeal
		Number - Kind Code (if known)			
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	AC	US-6,256,767	07-03-2001	Kuekes et al.	
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	BA	US-20040005258	01-08-2004	Fonash et al.	
Examiner Signature				Date Considered	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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		Art Unit	2876		
Sheet		of		Examiner Name	Hess, Daniel A.
				Attorney Docket Number	01-001701

	BB	US-20040031975	02-19-2004	Kern et al.	
	BC	US-20040036126	02-26-2004	Chau et al.	
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	BE	US-20040061422	04-01-2004	Avouris et al.	
	BF	US-20050064618	03-24-2005	Brown et al.	

FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T
		Country Code - Number - Kind Code (if known)					
	BG						
	BH						
	BI						

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and-or country where published.	T
	BJ		
	BK		
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	BM		
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